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(54) **OLEDs DOPED WITH PHOSPHORESCENT COMPOUNDS**

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(56) **References Cited**

U.S. PATENT DOCUMENTS

4,950,950	*	8/1990	Perry et al.	313/504
5,128,587		7/1992	Skotheim et al.	313/504
5,981,306		11/1999	Burrows et al.	438/22
5,986,268		11/1999	Forrest et al.	250/372
5,986,401		11/1999	Thompson et al.	313/504
5,998,803		12/1999	Forrest et al.	257/40
6,013,538		1/2000	Burrows et al.	438/22
6,013,982		1/2000	Thompson et al.	313/506
6,030,715		2/2000	Thompson et al.	428/690
6,045,930		4/2000	Thompson et al.	428/690
6,046,543		4/2000	Bulovic et al.	313/504
6,048,630		4/2000	Burrows et al.	428/690
6,091,195		7/2000	Forrest et al.	313/504
6,097,147	*	8/2000	Baldo et al.	313/506
6,111,902		8/2000	Kuzlov et al.	372/39
6,125,226		9/2000	Forrest et al.	385/131
5,203,974		4/1993	Kokado et al.	.

(List continued on next page.)

FOREIGN PATENT DOCUMENTS

0 704 915	4/1996	(EP) .
3-289090	12/1991	(JP) .
96/19792	6/1996	(WO) .
97/33296	9/1997	(WO) .
97/48115	12/1997	(WO) .
97/48139	12/1997	(WO) .

OTHER PUBLICATIONS

S. Hoshino et al., "Electroluminescence from Triplet Excited States of Benzophenone", *Appl. Phys. Lett.* 69(2), pp. 224-226, Jul. 1996.*

Bulovic et al., "Transparent Light-emitting Devices", *Nature* 380, 29 (Mar. 1996).

Whitlock et al., "Investigations of Materials and Device Structures for Organic Semiconductor Solar Cells", *Optical Eng.*, vol. 32, No. 8, 1921-1934 (Aug. 1993).

J. Kido, et al., "Electroluminescence in a Terbium Complex", *Chemistry Letters*, 1990, pp. 657-660 (No Month).

J. Kido, et al., "Organic electroluminescent devices using lanthanide complexes", *J. Alloys and Compounds*, 1993, 192, pp. 30-33 (No Month).

J. Kido, et al., "Bright red light-emitting organic electroluminescent devices having a europium complex as an emitter", *Appl. Phys. Lett.*, 65, pp. 2124-2126, Oct. 1994.

J. Kido, et al., "White-Light-Emitting Organic Electroluminescent Device Using Lanthanide Complexes," *Jpn. J. Appl. Phys.*, 35, pp. L394-L396, Mar. 1996.

S.R. Forrest, "Ultrathin Organic Films Grown by Organic Molecular Beam Deposition and Related Techniques," *Chemical Reviews*, 97, pp. 1793-1896, Sep./Oct. 1997.

C.W. Tang et al., "Organic electroluminescent diodes," *Appl. Phys. Lett.* 51, 913 (Sep. 1987).

S.R. Forrest et al., "Organic emitters promise a new generation of displays," *Laser Focus World*, Feb. 1995, pp. 99-107.

C. E. Johnson et al., "Luminescent Iridium (I), Rhodium (I), and Platinum (II) Dithiolate Complexes," *105 Journal of the American Chemical Society*, pp. 1795-1802. (1983) No Month.

Hosokawa et al., "Highly efficient blue electroluminescence from a distyrylarylene emitting layer with a new dopant" *Appl. Phys. Lett.*, 67(26), pp. 3853-3855 (Dec. 25, 1995).

Adachi et al., *Jpn. J. Appl. Phys.* 27:L269-L271, Feb. 1988.

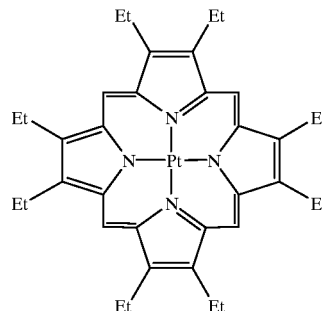
* cited by examiner

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(57) **ABSTRACT**

Organic light emitting devices are disclosed which are comprised of a heterostructure for producing electroluminescence wherein the heterostructure is comprised of an emissive layer containing a phosphorescent dopant compound. For example, the phosphorescent dopant compound may be comprised of platinum octaethylporphine (PtOEP), which is a compound having the chemical structure with the formula:



63 Claims, 3 Drawing Sheets

U.S. PATENT DOCUMENTS

5,231,329	7/1993	Nishikitani et al.	313/503	5,757,139	5/1998	Forrest et al.	315/169.3
5,294,810 *	3/1994	Egusa et al.	257/40	5,811,833	9/1998	Thompson	257/40
5,457,565	10/1995	Namiki et al.	359/273	5,834,130 *	11/1998	Kido et al.	428/690
5,540,999 *	7/1996	Yamamoto et al.	428/411.1	5,834,893	11/1998	Bulovic et al.	313/506
5,601,903 *	2/1997	Fujii et al.	428/212	5,844,363	12/1998	Gu et al.	313/506
5,703,436 *	12/1997	Forrest et al.	313/506	5,861,219	1/1999	Thompson et al.	428/690
5,707,745	1/1998	Forrest et al.	428/432	5,874,803	2/1999	Garbuzov et al.	313/506
5,756,224	5/1998	Bürner et al.	428/690	5,917,280	6/1999	Burrows et al.	313/506
5,757,026	5/1998	Forrest et al.	257/40	5,932,895	8/1999	Shen et al.	257/89
				5,953,587	9/1999	Forrest et al.	438/99

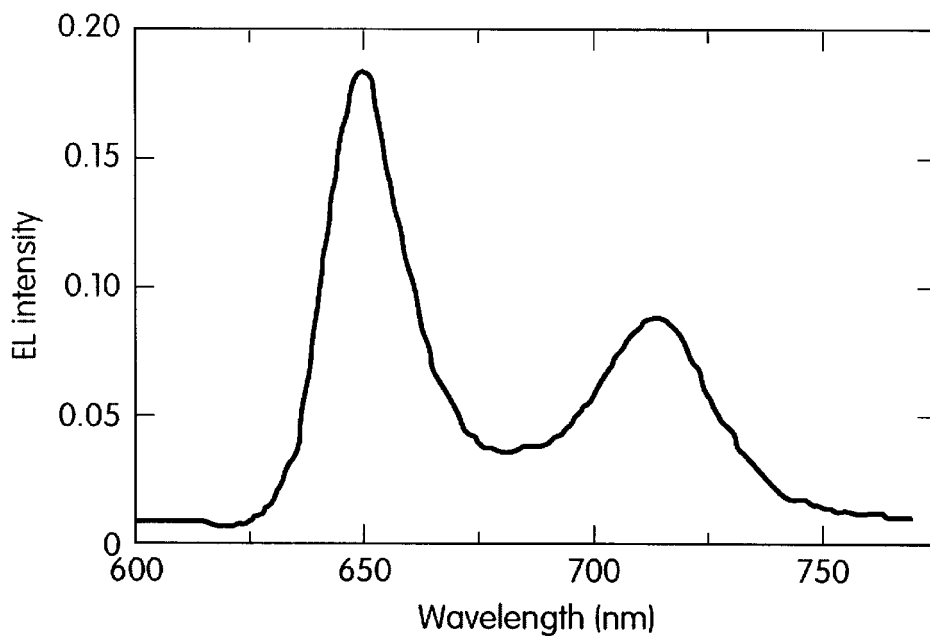


FIG. 1

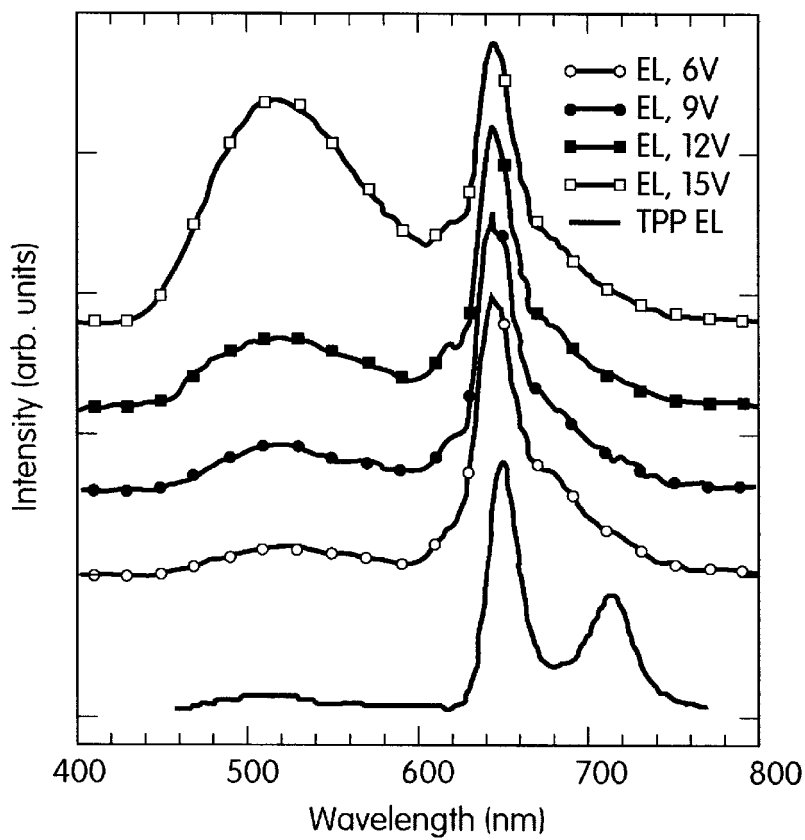


FIG. 2

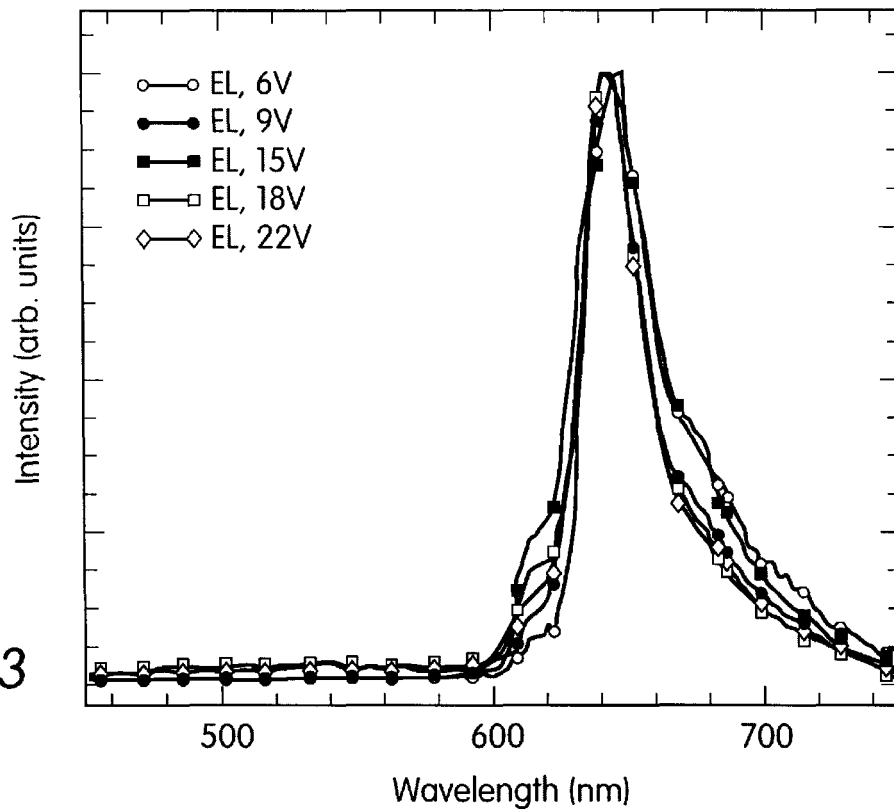


FIG. 3

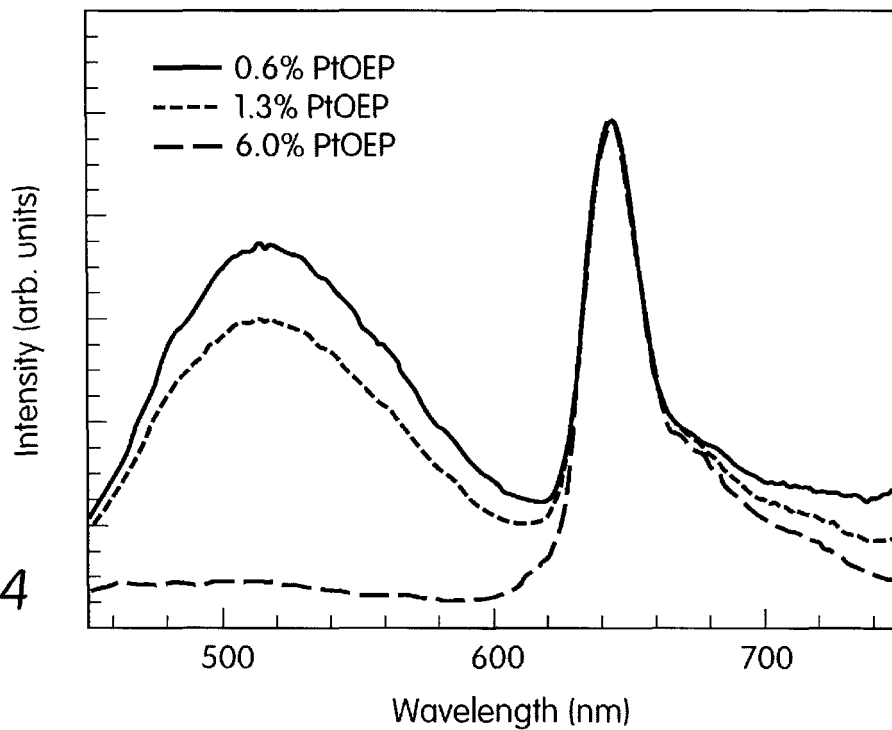


FIG. 4

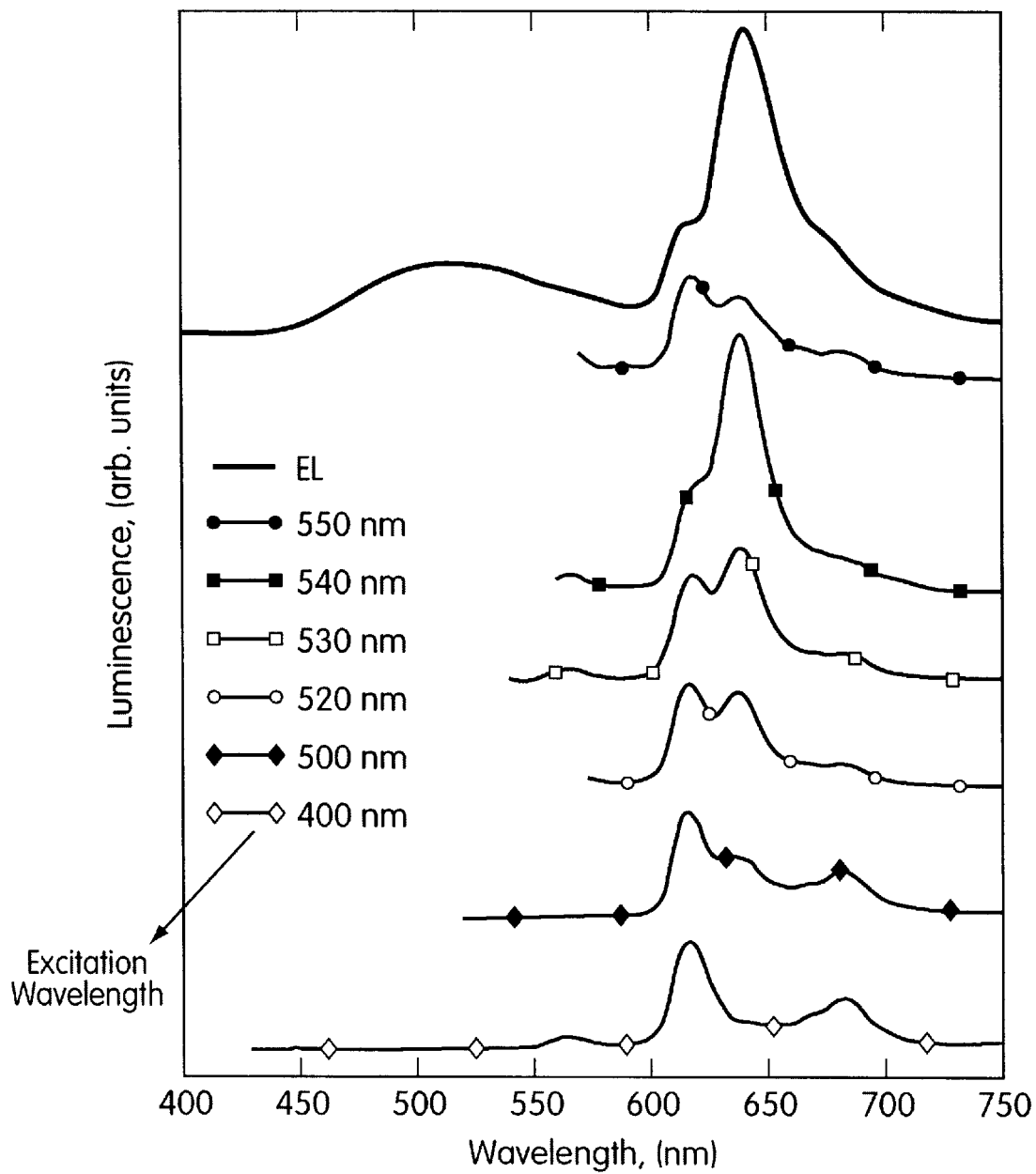


FIG. 5

OLEDs DOPED WITH PHOSPHORESCENT COMPOUNDS

FIELD OF INVENTION

The present invention is directed to organic light emitting devices (OLEDs) comprised of emissive layers that contain a phosphorescent dopant compound.

BACKGROUND OF THE INVENTION

Organic light emitting devices (OLEDs) are comprised of several organic layers in which one of the layers is comprised of an organic material that can be made to electroluminesce by applying a voltage across the device, C. W. Tang et al., *Appl. Phys. Lett* 51, 913 (1987). Certain OLEDs have been shown to have sufficient brightness, range of color and operating lifetimes for use as a practical alternative technology to LCD-based full color flat-panel displays (S. R. Forrest, P. E. Burrows and M. E. Thompson, *Laser Focus World*, February 1995). Since many of the thin organic films used in such devices are transparent in the visible spectral region, they allow for the realization of a completely new type of display pixel in which red (R), green (G), and blue (B) emitting OLEDs are placed in a vertically stacked geometry to provide a simple fabrication process, a small R-G-B pixel size, and a large fill factor, International Patent Application No. PCT/US95/15790.

A transparent OLED (TOLED), which represents a significant step toward realizing high resolution, independently addressable stacked R-G-B pixels, was reported in International Patent Application No. PCT/US97/02681 in which the TOLED had greater than 71% transparency when turned off and emitted light from both top and bottom device surfaces with high efficiency (approaching 1% quantum efficiency) when the device was turned on. The TOLED used transparent indium tin oxide (ITO) as the hole-injecting electrode and a Mg—Ag-ITO electrode layer for electron-injection. A device was disclosed in which the ITO side of the Mg—Ag-ITO electrode layer was used as a hole-injecting contact for a second, different color-emitting OLED stacked on top of the TOLED. Each layer in the stacked OLED (SOLED) was independently addressable and emitted its own characteristic color. This colored emission could be transmitted through the adjacently stacked, transparent, independently addressable, organic layer or layers, the transparent contacts and the glass substrate, thus allowing the device to emit any color that could be produced by varying the relative output of the red and blue color-emitting layers.

The PCT/US95/15790 application disclosed an integrated SOLED for which both intensity and color could be independently varied and controlled with external power supplies in a color tunable display device. The PCT/US95/15790 application, thus, illustrates a principle for achieving integrated, full color pixels that provide high image resolution, which is made possible by the compact pixel size. Furthermore, relatively low cost fabrication techniques, as compared with prior art methods, may be utilized for making such devices.

Such devices whose structure is based upon the use of layers of organic optoelectronic materials generally rely on a common mechanism leading to optical emission. Typically, this mechanism is based upon the radiative recombination of a trapped charge. Specifically, OLEDs are comprised of at least two thin organic layers separating the anode and cathode of the device. The material of one of these layers is specifically chosen based on the material's ability to transport holes, a "hole transporting layer" (HTL),

and the material of the other layer is specifically selected according to its ability to transport electrons, an "electron transporting layer" (ETL). With such a construction, the device can be viewed as a diode with a forward bias when the potential applied to the anode is higher than the potential applied to the cathode. Under these bias conditions, the anode injects holes (positive charge carriers) into the hole transporting layer, while the cathode injects electrons into the electron transporting layer. The portion of the luminescent medium adjacent to the anode thus forms a hole injecting and transporting zone while the portion of the luminescent medium adjacent to the cathode forms an electron injecting and transporting zone. The injected holes and electrons each migrate toward the oppositely charged electrode. When an electron and hole localize on the same molecule, a Frenkel exciton is formed. Recombination of this short-lived state may be visualized as an electron dropping from its conduction potential to a valence band, with relaxation occurring, under certain conditions, preferentially via a photoemissive mechanism. Under this view of the mechanism of operation of typical thin-layer organic devices, the electroluminescent layer comprises a luminescence zone receiving mobile charge carriers (electrons and holes) from each electrode.

The materials that produce the electroluminescent emission are frequently the same materials that function either as the electron transporting layer or as the hole transporting layer. Such devices in which the electron transporting layer or the hole transporting layer also functions as the emissive layer are referred to as having a single heterostructure.

Alternatively, the electroluminescent material may be present in a separate emissive layer between the hole transporting layer and the electron transporting layer in what is referred to as a double heterostructure.

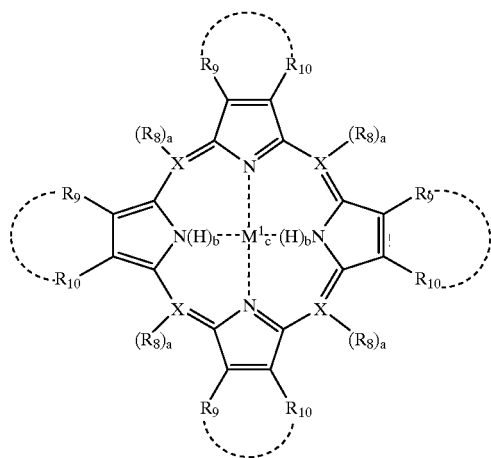
In addition to emissive materials that are present as the predominant component in the charge carrier layer, that is, either in the hole transporting layer or in the electron transporting layer, and that function both as the charge carrier material as well as the emissive material, the emissive material may be present in relatively low concentrations as a dopant in the charge carrier layer. Whenever a dopant is present, the predominant material in the charge carrier layer may be referred to as a host compound or as a receiving compound. Materials that are present as host and dopant are selected so as to have a high level of energy transfer from the host to the dopant material. In addition, these materials need to be capable of producing acceptable electrical properties for the OLED. Furthermore, such host and dopant materials are preferably capable of being incorporated into the OLED using starting materials that can be readily incorporated into the OLED by using convenient fabrication techniques, in particular, by using vacuum-deposition techniques.

It is desirable for OLEDs to be fabricated using materials that provide electroluminescent emission in a relatively narrow band centered near selected spectral regions, which correspond to one of the three primary colors, red, green and blue so that they may be used as a colored layer in an OLED or SOLED. It is also desirable that such compounds be capable of being readily deposited as a thin layer using vacuum deposition techniques so that they may be readily incorporated into an OLED that is prepared entirely from vacuum-deposited organic materials.

Co-pending U.S. Pat. No. 08/774,087, filed Dec. 23, 1996, now U.S. Pat. No. 6,048,630, is directed to OLEDs containing emitting compounds that produce a saturated red emission. The emission layer is comprised of an emitting

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compound having a chemical structure represented by Formula I:



wherein X is C or N;

R_8 , R_9 and R_{10} are each independently selected from the group consisting of hydrogen, alkyl, substituted alkyl, aryl and substituted aryl; wherein R_9 and R_{10} may be combined together to form a fused ring;

M_1 is a divalent, trivalent or tetravalent metal; and a, b and c are each 0 or 1;

wherein, when X is C, then a is 1; when X is N, then a is 0; when c is 1, then b is 0; and when b is 1, c is 0.

The examples disclosed in Ser. No. 08/774,087 (now U.S. Pat. No. 6,048,630) included an emissive compound of formula I wherein X=C; R_8 =phenyl;

R_9 = R_{10} =H; c=0; and b=1. This compound has the chemical name 5,10,15,20-tetraphenyl-21H,23H-porphine (TPP). OLEDs comprised of the TPP-containing emissive layer produce an emission spectrum comprised of two narrow bands that are centered at about 650 and about 713 nm, as shown in FIG. 1. The emission from this device involves fluorescence from the TPP dopant. One of the problems with the TPP-doped device is that the narrow band at 713 nm, which comprises about 40% of the emission, is not within a range that is useful for display applications. A second problem is that TPP-doped OLEDs are very unstable, such that the shelf life of such devices is typically very short. It would be desirable if these two aspects of TPP-doped devices could be improved. The present invention is directed to addressing these problems of prior art devices.

Another aspect of the present invention relates to the fact that, based on spin statistical arguments, it is generally understood that the majority of the excitons that are produced in an OLED are in a non-emissive triplet electronic state. Formation of such triplet states can result in a substantial loss of the excitation energy in the OLED via radiationless transitions to the ground state. It would be desirable if the total OLED quantum efficiency could be enhanced by utilizing this energy transfer pathway through the exciton triplet states, for example, by having the exciton triplet state energy transferred to an emissive material. Unfortunately, though it is known that the energy from an excited triplet state may be efficiently transferred under certain circumstances to the triplet state of a molecule that

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phosphoresces, the phosphorescent decay rate is typically not expected to be rapid enough to be adequate for use in a display device.

The present invention is further directed to OLEDs which also address such problems of prior art devices.

ADVANTAGES AND SUMMARY OF THE INVENTION

The present invention is directed to OLEDs, and a method of fabricating OLEDs, in which emission from the device is obtained via a phosphorescent decay process wherein the phosphorescent decay rate is rapid enough to meet the requirements of a display device.

More specifically, the present invention is directed to OLEDs comprised of a material that is capable of receiving the energy from an exciton singlet or triplet state and emitting that energy as phosphorescent radiation.

One of the benefits of the present invention is that the phosphorescent decay process utilizes exciton triplet state energy that is typically wasted in an OLED via a radiationless energy transfer and relaxation process.

The present invention is further directed to OLEDs that are capable of producing a highly saturated red emission. More specifically, OLEDs of the present invention are comprised of platinum octaethylporphine (PtOEP), a compound that produces a narrow emission band that peaks near 640 nm when the PtOEP is doped in an electron transporting layer comprised of tris-(8-hydroxyquinoline)-aluminum (Alq_3). Such emission is perceived as highly saturated red emission.

Another of the benefits of PtOEP-doped OLEDs is that such OLEDs have a stability, when the device is exposed to ambient environmental conditions for a few days, that is comparable to prior art devices and, in particular, a decidedly greater shelf life stability as compared with TPP-doped devices.

Further objectives and advantages of the present invention will be apparent to those skilled in the art from the detailed description of the disclosed invention.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 shows the electroluminescent (EL) spectrum of TPP-doped OLEDs.

FIG. 2 shows the EL spectra as a function of wavelength at different voltages (6, 9, 12 and 15V) for OLEDs having an Alq_3 layer doped with 0.6 mol % PtOEP as compared with the EL spectrum of a TPP-doped device ("TPP EL").

FIG. 3 shows the EL spectra as a function of wavelength at different voltages for OLEDs doped with about 6 mol % PtOEP.

FIG. 4 shows the photoluminescent (PL) spectra as a function of wavelength for different PtOEP concentrations for Alq_3 devices doped with PtOEP.

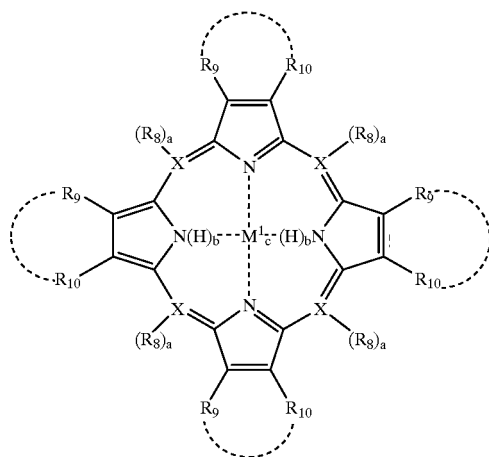
FIG. 5 shows the PL spectra as a function of wavelength at different excitation wavelengths for a solution of PtOEP as compared with the EL spectrum of an OLED having an Alq_3 layer doped with 0.6 mol % PtOEP.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

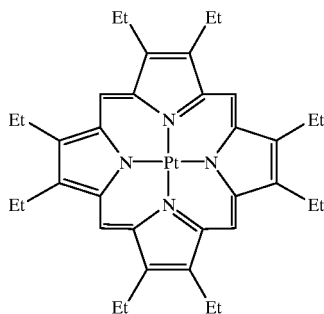
The present invention will now be described in detail for specific preferred embodiments of the invention, it being understood that these embodiments are intended only as illustrative examples and the invention is not to be limited thereto.

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The present invention is directed to OLEDs in which emission from the device is obtained via a phosphorescent decay process wherein the phosphorescent decay rate is rapid enough to meet the requirements of a display device. As a representative embodiment of the present invention the emission layer is comprised of an emitting compound having a structure represented by Formula I:



wherein $M=Pt$; $a=1$; $b=0$; $c=1$; $X=C$; and $R_8=H$; and $R_9=R_{10}=Et$ (ethyl). In particular, this compound, platinum octaethylporphyrine (PtOEP), has the chemical structure of formula II:



The advantage of selecting a dopant compound such as PtOEP as the emissive material of an OLED is based, inter alia, on two particular facts. First, the photoluminescent quantum yield for this molecule is significantly greater than TPP, PtOEP having a photoluminescent quantum yield of greater than 50%, and as high as 90% in the solid state, and TPP having a photoluminescent quantum yield of only about 10%. The improved photoluminescent quantum yield makes it possible to fabricate OLEDs with increased efficiencies. A second advantage that is offered by selecting a phosphorescent compound such as PtOEP is that the emission from such a molecule comes from a triplet state. A molecule that is capable of being excited to a triplet state provides the possibility of having the energy transferred from the non-emissive exciton triplet state to a triplet state that is capable of radiatively emitting this energy as phosphorescent radiation. Though phosphorescence, which refers to radiation that comes from a triplet state, typically occurs at a much slower rate than fluorescence, which refers to radiation from a singlet state, the phosphorescence from a compound such as

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PtOEP is, nevertheless, sufficiently rapid to satisfy the requirements of certain display devices. In particular, a compound such as PtOEP, which has a lifetime of about 7 μsec when used as the dopant in an Alq_3 layer, may be used in passive matrix displays that require a switching time of not faster than about 10 μsec or in an active matrix display for which the switching time only needs to be about 10 msec.

As a representative embodiment of the present invention, the PtOEP may be doped into the Alq_3 layer of an ITO/TPD/ Alq_3 /Mg—Ag OLED. The behavior of such PtOEP-doped OLEDs is very different from OLEDs prepared with TPP dopants. At doping levels greater than 0.5 mol % TPP, the emission from the OLED is exclusively from the TPP. In contrast, at low to moderate doping levels of PtOEP in Alq_3 , the emission is dominated by PtOEP emission at low voltage, but as the voltage is increased, Alq_3 emission appears. At moderately high voltages (e.g., 15 V) the majority of the emission comes from Alq_3 . The EL spectra for a 0.6 mol % PtOEP doped OLED are given in FIG. 2. The spectra for 1.3 mol % PtOEP have about the same shape as those shown for the 0.6 mol % device. The shape of the spectra of an OLED prepared with 6 mol % PtOEP are shown in FIG. 3. As the voltage is increased, the intensity of the red emission increases significantly, but a contribution from Alq_3 emission is not observed, even at a high voltage.

While the present invention is not limited by the theory of how it works, it is believed that the explanation for the increase in Alq_3 emission as the voltage is increased is related to the different lifetimes for photoluminescence for Alq_3 and PtOEP. The PL lifetime for Alq_3 is about 13 nsec (nanoseconds) in both the solid state and in solution, whereas the PL lifetime of PtOEP varies from about 10 to about 100 μsec (microseconds) depending on the medium. If the voltage applied to the PtOEP-doped device is kept low, the number of excitons transferred to PtOEP is small enough such that the excited PtOEP molecules can relax at a sufficient rate relative to the Alq_3 exciton creation rate, with the result that there are always enough dopant molecules for energy transfer from the Alq_3 . As the voltage is increased, the available PtOEP dopant molecules become saturated and cannot relax fast enough to keep up with the rate at which the excitons are being created in the Alq_3 . In this higher voltage regime, some of the Alq_3 excitons relax by radiative emission before the excitation energy can be transferred to the PtOEP molecules. At 6 mol % PtOEP, enough dopant is present to trap all of the excitons, but the higher doping levels lead to decreased overall efficiency.

This explanation is further supported by the results shown in FIG. 4, which show the PL spectra as a function of wavelength at different doping levels for PtOEP-doped Alq_3 devices. At the lowest doping levels of 0.6 mol %, a large emission band characteristic of Alq_3 is observed, whereas for the high 6 mol % PtOEP-doping level, there appears to be sufficient PtOEP present to capture all the exciton energy from the Alq_3 .

The emission from the PtOEP-based OLEDs is very narrow and centered at 645 nm. This narrow band, which corresponds to saturated red emission, has a full width at half maximum of about 30 nm. A comparison of the PL spectra as a function of wavelength at different excitation wavelengths for PtOEP in solution, as shown in FIG. 5, with the EL spectrum of a PtOEP-doped Alq_3 OLED, shows that a PtOEP-doped OLED selectively produces the narrow band of emission from PtOEP that is centered with a peak at about 645 nm. This narrow, highly saturated red emission is produced, with almost the total absence of the other PtOEP peaks, even though a comparison of the PL excitation

of the dopant's excited state excitation energy is said to have a quantum efficiency of 100%. For host/dopant concentrations which are to be used in a color tunable SOLED, preferably most, if not all, of the host's excitation energy is transferred to the dopant which in turn radiates, perhaps

from a lower energy level, but with a high quantum efficiency, to produce visible radiation having a desired chromaticity. The present invention is directed toward phosphorescent compounds that are intended to serve as dopants which satisfy these demanding energy transfer requirements.

As the term host compound is used herein, it will be appreciated that such compounds can be found in an electron transporting/emissive layer or a hole transporting/emissive layer of a single heterostructure OLED device or in the separate emissive layer of a double heterostructure device.

As will be recognized by one of skill in the art, use of the dopant species such as disclosed herein makes it possible to extend not only the range of colors emitted by the OLED, but also to extend the range of possible candidate species for host and/or dopant compounds. Accordingly, for effective host/dopant systems, although the host compound can have a strong emission in a region of the spectrum where the dopant species strongly absorbs light, the host species preferably does not have an emission band in a region where the dopant also emits strongly. In structures where the host compound also functions as a charge carrier, then additional criteria such as redox potential for the species also becomes a consideration. In general, however, the spectral characteristics of the host and dopant species are the most important criteria.

The amount of dopant that is present is that amount which is sufficient to shift the emission wavelength of the host material as close as possible to a saturated primary color, as that would be defined according to the CIE scale. Typically, the effective amount is from about 0.01 to 10.0 mol %, based on the emitting layer. The primary criterion for determining an appropriate doping level is the level which is effective for achieving an emission with the appropriate spectral characteristics. By way of example, and without limitation, if the amount of dopant species is at too low a level, then emission from the device will also comprise a component of light from the host compound itself, which will be at shorter wavelengths than the desired emission from the dopant species. In contrast, if the level of dopant is too high, emission efficiencies could be adversely affected by self-quenching, a net non-emissive mechanism. Alternatively, too high levels of the dopant species could also adversely affect the hole or electron transporting properties of the host material.

The OLEDs of the present invention are comprised of a heterostructure for producing electroluminescence which may be fabricated as a single heterostructure or as a double heterostructure. The materials, methods and apparatus for preparing the organic thin films of a single or double heterostructure are disclosed, for example, in U.S. Pat. No. 5,554,220, which is incorporated herein in its entirety by reference. As used herein, the term "heterostructure for producing electroluminescence" refers to a heterostructure that includes, for a single heterostructure, in sequence, a hole injecting anode layer, a hole transporting layer, an electron transporting layer, and a cathode layer. An additional layer or layers may be present between one or more of the sequential pairs of these layers. For example, for a double heterostructure, a separate emissive layer is included between the hole transporting layer and the electron transporting layer. This separate emissive layer may be characterized as being a "thin luminescent layer." Alternatively, or

in addition, a hole injection enhancement layer may be present between the anode layer and the hole transporting layer and/or an electron injecting and interface layer may be present between the cathode layer and the electron transporting layer.

Either the anode layer or the cathode layer may be in contact with a substrate and each electrode is connected to electrical contacts which are capable of delivering a voltage across the device causing it to produce electroluminescence from an electron transporting layer, a hole transporting layer or a separate emissive layer. If the cathode layer is deposited on the substrate, the device may be referred to as having an inverted OLED (IOLED) structure. An inverted structure may also be referred to as an "OILED" structure. If the heterostructure for producing electroluminescence is included as part of a stacked OLED (SOLED), one or both of the electrodes of an individual heterostructure may be in contact with an electrode of an adjacent heterostructure. Alternatively, dependent on the circuitry used to drive the SOLED, an insulating layer may be provided between the adjacent electrodes of the OLEDs in the stack.

The single or double heterostructures as referred to herein are intended solely as examples for showing how an OLED embodying the present invention may be fabricated without in any way intending the invention to be limited to the particular materials or sequence for making the layers shown. For example, a single heterostructure typically includes a substrate which may be opaque or transparent, rigid or flexible, and/or plastic, metal or glass; a first electrode, which is typically a high work function, hole-injecting anode layer, for example, an indium tin oxide (ITO) anode layer; a hole transporting layer; an electron transporting layer; and a second electrode layer, for example, a low work function, electron-injecting, metal cathode layer of a magnesium-silver alloy, (Mg:Ag) or of a lithium-aluminum alloy, (Li:Al). Alternatively, as disclosed in the recently filed application entitled "A Highly Transparent Organic Light Emitting Device Employing a Non-Metallic Cathode" filed Nov. 5, 1997, which is incorporated in its entirety by reference, the cathode may be a non-metallic material such as ITO, the term "non-metallic" being used to embrace still other transparent conducting inorganic layers, as well as materials comprised of metals that may be present as one of the elements in a chemical compound, for example, as an oxide. However, the term "non-metallic" does not embrace materials comprised predominantly of the free metal nor does the term embrace metal alloys.

Materials that may be used as the substrate in a representative embodiment of the present invention include, in particular, glass, transparent polymer such as polyester, sapphire or quartz, or substantially any other material that may be used as the substrate of an OLED.

Materials that may be used as the hole-injecting anode layer in a representative embodiment of the present invention include, in particular, ITO, Zn—In—SnO₂ or SbO₂, or substantially any other material that may be used as the hole-injecting anode layer of an OLED.

Materials that may be used in the hole transporting layer in a representative embodiment of the present invention include, in particular, N,N'-diphenyl-N,N'-bis(3-methylphenyl)-1-1'-biphenyl-4,4'-diamine (TPD), 4,4'-bis[N-(1-naphthyl)-N-phenyl-amino]biphenyl (α -NPD) or 4,4'-bis[N-(2-naphthyl)-N-phenyl-amino]biphenyl (β -NPD).

Materials that may be used as the electron transporting layer include, in particular, tris-(8-hydroxyquinoline)-aluminum (Alq₃) and carbazole.

Materials that may be used as the separate emissive layer, if present, include, in particular, dye-doped Alq₃, or sub-

stantially any other material that may be used as the separate emissive layer of an OLED.

The insulating layer, if present, may be comprised of an insulating material such as SiO₂, SiN_x or AlO₂, or substantially any other material that may be used as the insulating material of an OLED, which may be deposited by a variety of processes such as plasma enhanced chemical vapor deposition (PECVD), electron beam, etc.

The hole injecting enhancement layer may in some cases be comprised of the same material, CuPc, as is used in the electron injecting and interface layer. In each case, the CuPc layer may be in direct contact with an ITO electrode, with the distinction between the two CuPc layers being that in one case the CuPc layer is in contact with an ITO layer that functions as an anode and in the other case the ITO layer functions as a cathode. In each case, the CuPc layer functions as a charge carrier and interface layer. On the one hand when in contact with the ITO anode, the CuPc layer assists in injecting and transporting holes from the anode to a hole transporting layer, and on the other hand when in contact with the ITO cathode, the CuPc layer assists in injecting and transporting electrons from the cathode to an electron transporting layer. The term "electron injecting interface layer" is used to refer to this layer that is present between and in contact with the cathode layer and the electron transporting layer of the heterostructure. The CuPc layer, in each case, may also function as a protection layer that protects any underlying organic layers, if present, from damage during the ITO deposition process. The protection layer may also be comprised of others materials such as 3,4,9,10-perylenetetracarboxylic dianhydride (PTCDA). Whenever the ITO layer is present as the electrode in a SOLED structure, opposite faces of the ITO may function as an anode and cathode, respectively.

The OLEDs of the present invention have the advantage that they can be fabricated entirely from vacuum-deposited molecular organic materials as distinct, for example, from OLEDs in which some of the layers are comprised of polymeric materials, which cannot be readily deposited using vacuum deposition techniques. A vacuum-deposited material is one which can be deposited in a vacuum typically having a background pressure less than one atmosphere, preferably about 10⁻⁵ to about 10⁻¹¹ torr for vacuum deposition, or about 50 torr to about 10⁻⁵ torr for vapor deposition.

Although not limited to the thickness ranges recited herein, the substrate may be as thin as 10 μ, if present as a flexible plastic or metal foil substrate, such as aluminum foil, or substantially thicker if present as a rigid, transparent or opaque, substrate or if the substrate is comprised of a silicon-based display driver; the ITO anode layer may be from about 500 Å (1 Å=10⁻⁸ cm) to greater than about 4000 Å thick; the hole transporting layer from about 50 Å to greater than about 1000 Å thick; the separate emissive layer of a double heterostructure, if present, from about 50 Å to about 200 Å thick; the electron transporting layer from about 50 Å to about 1000 Å thick; and the metal cathode layer from about 50 Å to greater than about 100 Å thick, or substantially thicker if the cathode layer includes a protective silver layer and is opaque.

Thus, while there may be substantial variation in the type, number, thickness and order of the layers that are present, dependent on whether the device includes a single heterostructure or a double heterostructure, whether the device is a SOLED or a single OLED, whether the device is a TOLED or an IOLED, whether the OLED is intended to produce emission in a preferred spectral region, or whether still other

design variations are used, the present invention is directed to those devices in which the OLED is comprised of a heterostructure for producing electroluminescence wherein the heterostructure is comprised of an emissive layer containing a phosphorescent compound.

The subject invention as disclosed herein may be used in conjunction with co-pending applications: "High Reliability, High Efficiency, Integratable Organic Light Emitting Devices and Methods of Producing Same", Ser. No. 08/774,119 (filed Dec. 23, 1996), now U.S. Pat. No. 6,046,543; "Novel Materials for Multicolor Light Emitting Diodes", Ser. No. 08/850,264 (filed May 2, 1997), now U.S. Pat. No. 6,045,930; "Electron Transporting and Light Emitting Layers Based on Organic Free Radicals", Ser. No. 08/774,120 (filed Dec. 23, 1996), now U.S. Pat. No. 5,811,833; "Multicolor Display Devices", Ser. No. 08/772,333 (filed Dec. 23, 1996), now U.S. Pat. No. 6,013,982; "Red-Emitting Organic Light Emitting Devices (OLED's)", Ser. No. 08/774,087 (filed Dec. 23, 1996), now U.S. Pat. No. 6,048,630; "Driving Circuit For Stacked Organic Light Emitting Devices", Ser. No. 08/792,050 (filed Feb. 3, 1997)(U.S. Pat. No. 5,757,139); "High Efficiency Organic Light Emitting Device Structures", Ser. No. 08/772,332 (filed Dec. 23, 1996)(U.S. Pat. No. 5,834,893); "Vacuum Deposited, Non-Polymeric Flexible Organic Light Emitting Devices", Ser. No. 08/789,319 (filed Jan. 23, 1997)(U.S. Pat. No. 5,844,363); "Displays Having Mesa Pixel Configuration", Ser. No. 08/794,595 (filed Feb. 3, 1997), now U.S. Pat. No. 6,091,195; "Stacked Organic Light Emitting Devices", Ser. No. 08/792,046 (filed Feb. 3, 1997)(U.S. Pat. No. 5,927,280); "High Contrast Transparent Organic Light Emitting Device Display", Ser. No. 08/821,380 (filed Mar. 20, 1997), now U.S. Pat. No. 5,986,401; "Organic Light Emitting Devices Containing A Metal Complex of 5-Hydroxy-Quinoxaline as A Host Material", Ser. No. 08/838,099 (filed Apr. 15, 1997)(U.S. Pat. No. 5,861,219); "Light Emitting Devices Having High Brightness", Ser. No. 08/844,353 (filed Apr. 18, 1997), now U.S. Pat. No. 6,125,226; "Organic Semiconductor Laser", Ser. No. 08/859,468 (filed May 19, 1997), now U.S. Pat. No. 6,111,902; "Saturated Full Color Stacked Organic Light Emitting Devices", Ser. No. 08/858,994 (filed on May 20, 1997), now U.S. Pat. No. 5,932,895; "An Organic Light Emitting Device Containing a Hole Injection Enhancement Layer", Ser. No. 08/865,491 (filed May 29, 1997), now U.S. Pat. No. 5,998,803; "Plasma Treatment of Conductive Layers", PCT/US97/10252, (filed Jun. 12, 1997); "Patterning of Thin Films for the Fabrication of Organic Multi-color Displays", PCT/US97/10289, (filed Jun. 12, 1997); "OLEDs Containing Thermally Stable Asymmetric Charge Carrier Materials", Ser. No. 08/929,029, filed Sep. 8, 1997, now U.S. Pat. No. 6,242,115; "Light Emitting Device with Stack of OLEDs and Phosphor Downconverter", Ser. No. 08/925,403, (filed Sep. 9, 1997) (U.S. Pat. No. 5,874,803); "An Improved Method for Depositing Indium Tin Oxide Layers in Organic Light Emitting Devices", Ser. No. 08/928,800 (filed Sep. 12, 1997), now U.S. Pat. No. 5,981,306; "Azlactone-Related Dopants in the Emissive Layer of an Oled" (filed Oct. 9, 1997), Ser. No. 08/948,130, "A Highly Transparent Organic Light Emitting Device Employing A Non-Metallic Cathode", (filed Nov. 3, 1997) now U.S. Pat. No. 6,030,715; (Provisional), "A Highly Transparent Organic Light Emitting Device Employing a Non-Metallic Cathode", (filed Nov. 5, 1997), (Ser. No. 08/964,863), "Low Pressure Vapor Phase Deposition of Organic Thin Films" (filed Nov. 17, 1997), (Ser. No. 08/972,156), "Method of Fabricating and Patterning Oleds", (filed Nov. 24, 1997), (Ser. No. 08/977,205),

"Method for Deposition and Patterning of Organic Thin Film", (filed Nov. 24, 1997) now U.S. Pat. No. 6,013,538; (Ser. No. 08/976,666), now U.S. Pat. No. 5,953,587; each co-pending application being incorporated herein by reference in its entirety. The subject invention may also be used in conjunction with the subject matter of each of co-pending U.S. patent application Ser. No. 08/354,674 (U.S. Pat. No. 5,707,745), U.S. Ser. No. 08/613,207 (U.S. Pat. No. 5,703,436), U.S. Ser. No. 08/632,322 (U.S. Pat. No. 5,757,026) and U.S. Ser. No. 08/693,359 and provisional patent application Serial No. 60/010,013 (U.S. Ser. No. 08/779,141, filed Jan. 6, 1997, Allowed) U.S. Ser. No. 60/024,001 (U.S. Ser. No. 08/789,319, filed Jan. 23, 1997, U.S. Pat. No. 5,844,363) U.S. Ser. No. 60/025,501 (U.S. Ser. No. 08/844,353, filed Apr. 18, 1997), U.S. Ser. No. 60/046,061 (U.S. Ser. No. 09/010,594, filed Jan. 22, 1998) and U.S. Ser. No. 60/053,176, each of which is also incorporated herein by reference in its entirety.

The materials that may be used as the substrate, the hole-injecting anode layer, the hole transporting layer, the electron transporting layer, the electron-injecting, metal cathode layer or the electron-injecting, non-metallic cathode layer, the protection layer, if present, the separate emissive layer, if present, or the insulating layer, if present, include the materials as disclosed in these co-pending applications.

The OLED of the present invention may be used in substantially any type of device which is comprised of an OLED, for example, in OLEDs that are incorporated into a larger display, a vehicle, a computer, a television, a printer, a large area wall, theater or stadium screen, a billboard or a sign.

This invention will now be described in detail with respect to showing how certain specific representative embodiments thereof can be made, the materials, apparatus and process steps being understood as examples that are intended to be illustrative only. In particular, the invention is not intended to be limited to the methods, materials, conditions, process parameters, apparatus and the like specifically recited herein.

AN EXAMPLE OF THE INVENTION

The procedures that were used for fabrication of Organic Light-Emitting Devices (OLEDs) were as follows:

The hole transporting material TPD and the electron transporting material Alq₃ were synthesized according to literature procedures, and were sublimed before use. The dopant PtOEP was purchased from Porphyrin Products, Inc., Logan, UT, and was used as received.

OLEDs were prepared using the following procedures: The ITO/Borosilicate substrates (100Ω/square) were cleaned by sonicating with detergent for five minutes followed by rinsing with deionized water. They were then treated twice in boiling 1,1,1-trichloroethane for two minutes. The substrates were then sonicated twice with acetone for two minutes and twice with methanol for two minutes.

The background pressure prior to deposition was normally 7×10^{-7} torr or lower and the pressure during the deposition was around 5×10^{-7} to 1.1×10^{-6} torr.

All the chemicals were resistively heated in various tantalum boats. TPD was first deposited at a rate from one to four Å/s. The thickness was typically controlled at 300 Å.

The electron transporting layer Alq₃ was doped with PtOEP.

Typically, the dopant was first vaporized with the substrates covered. After the rate of the dopant was stabilized, the host material was vaporized to the certain rate. The cover

over the substrates was then opened and the host and guest were deposited at the desired concentration. The rate of dopant was normally 0.1–0.2 Å/s. The total thickness of this layer was controlled at about 450 Å.

The substrates were removed from the deposition system and masks were put directly on the substrates. The masks were made of stainless steel sheet and contain holes with diameters of 0.25, 0.5, 0.75 and 1.0 mm. The substrates were then put back into vacuum for further coating.

Magnesium and silver were co-deposited at a rate normally of 2.6 Å/s. The ratio of Mg:Ag varied from 7:1 to 12:1. The thickness of this layer was typically 500 Å. Finally, 1000 Å Ag was deposited at the rate between one to four Å/s.

The devices were characterized within five hours of fabrication. Typically electroluminescent spectra, I–V curves, and quantum yields were measured from direct front.

What is claimed is:

1. An organic electroluminescent emissive layer comprising a charge carrying, host material and a phosphorescent material, wherein the phosphorescent material is present in a lower concentration than the charge carrying, host material and the phosphorescent material emits phosphorescent radiation from a triplet molecular excited state when a voltage is applied across the electroluminescent emissive layer.

2. The organic electroluminescent layer of claim 1 wherein the phosphorescent material is present at a concentration from about 0.01 to 10.0 mol % based on the electroluminescent layer.

3. The organic electroluminescent layer of claim 1 wherein the charge carrying, host material is a hole transporting material.

4. The organic electroluminescent layer of claim 1 wherein the charge carrying, host material is an electron transporting material.

5. The organic electroluminescent layer of claim 1 wherein the phosphorescent material has a phosphorescent lifetime not longer than about 10 microseconds.

6. The organic electroluminescent layer of claim 1 wherein the phosphorescent lifetime from about 10 to about 100 microseconds.

7. A device for producing electroluminescence comprising an organic light emitting device including a phosphorescent material and a charge carrying host material, wherein the phosphorescent material emits phosphorescent radiation from a triplet molecular excited state when a voltage is applied across the organic light emitting device.

8. The device of claim 7 wherein the phosphorescent material has a phosphorescent lifetime not longer than about 10 microseconds.

9. The device of claim 7 wherein the phosphorescent material has a phosphorescent lifetime from about 10 to about 100 microseconds.

10. The device of claim 7 wherein the phosphorescent radiation produces a primary color.

11. The device of claim 10 wherein the primary color is red.

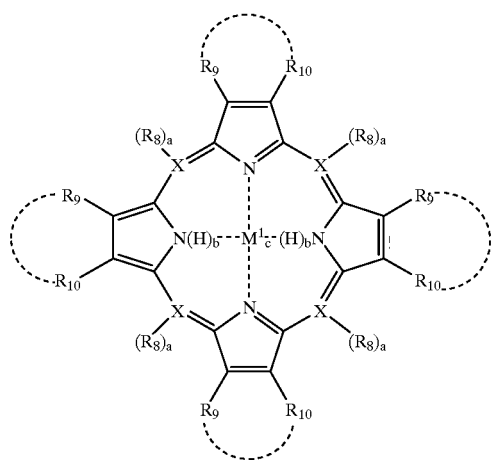
12. The device of claim 10 wherein the primary color is green.

13. The device of claim 10 wherein the primary color is blue.

14. A device for producing electroluminescence comprising an organic light emitting device including an emissive layer that emits phosphorescent radiation from a triplet molecular excited state when a voltage is applied across the device, wherein the emissive layer includes a host material

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and a phosphorescent material, the phosphorescent material having the chemical structure of formula I:



wherein X is C or N;

R_8 , R_9 and R_{10} are each independently selected from the group consisting of hydrogen, alkyl, substituted alkyl, aryl and substituted aryl;

R_9 and R_{10} may be combined together to form a fused ring;

M_1 is a divalent, trivalent or tetravalent metal; and

a, b and c are each 0 or 1;

wherein, when X is C, then a is 1; when X is N, then a is 0;

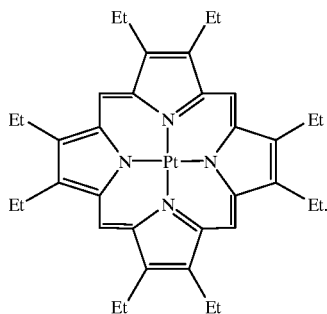
when c is 1, then b is 0; and when b is 1, c is 0.

15. The device of claim 14 wherein the phosphorescent material is present at a concentration from about 0.01 to 10.0 mol % based on the emissive layer.

16. The device of claim 14 wherein M_1 is a tetravalent metal.

17. The device of claim 14 wherein M_1 is Pt.

18. The device of claim 14 wherein the phosphorescent material is platinum octaethylporphine and has the chemical structure with the formula, wherein Et is an ethyl group:



19. The device of claim 14 wherein the phosphorescent material has a phosphorescent lifetime not longer than about 10 microseconds.

20. The device of claim 14 wherein the phosphorescent material has a phosphorescent lifetime from about 10 to about 100 microseconds.

21. The device of claim 14 wherein the phosphorescent radiation produces a primary color.

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22. The device of claim 21 wherein the primary color is red.

23. The device of claim 21 wherein the primary color is green.

24. The device of claim 21 wherein the primary color is blue.

25. The device of claim 14 wherein the phosphorescent radiation peaks at about 640 nm.

26. A device for producing electroluminescence comprising an organic light emitting device having an emissive layer comprised of a charge carrying, host material and a phosphorescent material, wherein the phosphorescent material is present at a lower concentration than the charge carrying, host material, and wherein the phosphorescent material emits phosphorescent radiation from a triplet molecular excited state when a voltage is applied across the organic light emitting device.

27. The device of claim 26 wherein the emissive layer is vapor-deposited.

28. The device of claim 26 wherein the emissive layer is vacuum-deposited.

29. The device of claim 26 wherein the phosphorescent material is present at a concentration from about 0.01 to 10.0 mol % based on the emissive layer.

30. The device of claim 26 wherein the charge carrying, host material is a hole transporting material.

31. The device of claim 26 wherein the charge carrying, host material is an electron transporting material.

32. The device of claim 26 wherein the phosphorescent material has a phosphorescent lifetime not longer than about 10 microseconds.

33. The device of claim 26 wherein the phosphorescent material has a phosphorescent lifetime from about 10 to about 100 microseconds.

34. The device of claim 26 wherein the organic light emitting device comprises a heterostructure.

35. The device of claim 34 wherein the heterostructure comprises, in sequence, an anode layer, a hole transporting layer, an electron transporting layer, and a cathode layer, wherein the emissive layer is the electron transporting layer.

36. The device of claim 35 wherein the electron transporting layer comprises tris-(8-hydroxyquinoline)-aluminum.

37. The device of claim 35 wherein the hole transporting layer comprises N,N'-diphenyl-N,N'-bis(3-methylphenyl)-1,1'-biphenyl-4,4'-diamine.

38. The device of claim 35 wherein a substrate is present on the anode side of the light emitting device.

39. The device of claim 35 wherein a substrate is present on the cathode side of the light emitting device.

40. The device of claim 34 wherein the heterostructure comprises, in sequence, an anode layer, a hole transporting layer, an electron transporting layer, and a cathode layer, wherein the emissive layer is the hole transporting layer.

41. The device of claim 34 wherein the heterostructure comprises, in sequence, an anode layer, a hole transporting layer, an electron transporting layer, and a cathode layer, wherein the emissive layer is between the electron transporting layer and the hole transporting layer.

42. The device of claim 26 wherein the phosphorescent radiation produces a primary color.

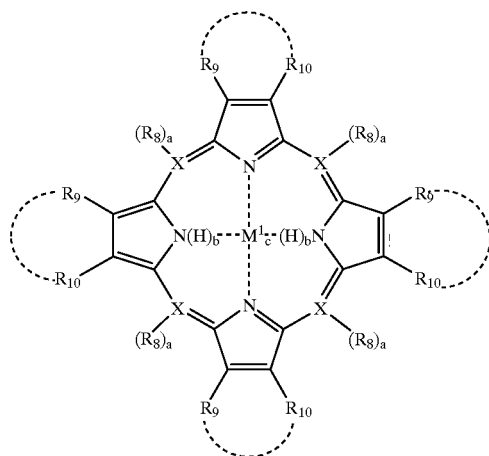
43. The device of claim 42 wherein the primary color is red.

44. The device of claim 42 wherein the primary color is green.

45. The device of claim 42 wherein the primary color is blue.

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46. A stacked organic light emitting device comprising:
 a first organic light emitting device for producing light of
 a first color; and
 a second organic light emitting device for producing light
 of a second color; the second organic light emitting
 device being stacked on the first organic light emitting
 device;
 wherein at least one of the organic light emitting devices
 includes a phosphorescent material in a charge
 carrying, host material, and wherein the phosphores-
 cent material emits phosphorescent radiation from a
 triplet molecular excited state when a voltage is applied
 across the at least one organic light emitting device.
 47. A stacked organic light emitting device comprising
 a first organic light emitting device for producing light of
 a first color; and
 a second organic light emitting device for producing light
 of a second color; the second organic light emitting
 device being stacked on the first organic light emitting
 device;
 wherein at least one of the organic light emitting devices
 includes an emissive layer that emits phosphorescent
 radiation from a triplet molecular excited state when a
 voltage is applied across the device, wherein the emis-
 sive layer includes a host material and a phosphores-
 cent material, the phosphorescent material having the
 chemical structure of formula I:



wherein X is C or N;

R_8 , R_9 and R_{10} are each independently selected from the
 group consisting of hydrogen, alkyl, substituted alkyl,
 aryl and substituted aryl;

R_9 and R_{10} may be combined together to form a fused
 ring;

M_1 is a divalent, trivalent or tetravalent metal; and
 a, b and c are each 0 or 1;

wherein, when X is C, then a is 1; when X is N, then a is
 0;

when c is 1, then b is 0; and when b is 1, c is 0.

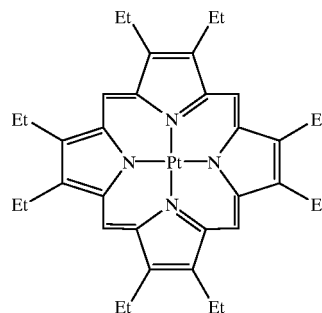
48. The stacked organic light emitting device of claim 47
 wherein M_1 is a tetravalent metal.

49. The stacked organic light emitting device of claim 47
 wherein M_1 is Pt.

50. The stacked organic light emitting device of claim 47 wherein the phosphorescent material

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is platinum octaethylporphine and has the chemical structure
 with the formula, wherein Et is an ethyl group:



51. A method of manufacturing a light emitting device
 comprising:

fabricating an organic light emitting device including an
 emissive layer, wherein the fabrication process
 includes the step of depositing a phosphorescent mate-
 rial and a charge carrying, host material to form the
 emissive layer, wherein the phosphorescent material
 emits phosphorescent radiation from a triplet molecular
 excited state when a voltage is applied across the
 device.

52. The method of claim 51 wherein the emissive layer is
 vapor-deposited.

53. The method of claim 51 wherein the emissive layer is
 vacuum-deposited.

54. The method of claim 51 wherein the phosphorescent
 material has a phosphorescent lifetime not longer than about
 10 microseconds.

55. The method of claim 51 wherein the phosphorescent
 material has a phosphorescent lifetime from about 10 to
 about 100 microseconds.

56. A method of manufacturing a light emitting device
 comprising:

fabricating an organic light emitting device including an
 emissive layer; wherein the fabrication process
 includes the step of depositing a charge carrying, host
 material together with a phosphorescent material to
 form the emissive layer, wherein the phosphorescent
 material has a lower concentration in the emissive layer
 than the charge carrying material and the phosphores-
 cent material emits phosphorescent radiation from a
 triplet molecular excited state when a voltage is applied
 across the organic light emitting device.

57. The method of claim 56 wherein the step of depositing
 the charge carrying, host material together with the phos-
 phorescent material to form the emissive layer comprises
 vapor depositing the charge carrying, host material together
 with the phosphorescent material to form the emissive layer.

58. The method of claim 56 wherein the step of depositing
 the charge carrying, host material together with the phos-
 phorescent material to form the emissive layer comprises
 vacuum depositing the charge carrying, host material
 together with the phosphorescent material to form the emis-
 sive layer.

59. The method of claim 56 wherein the phosphorescent
 material is present at a concentration from about 0.01 to 10.0
 mol % based on the emissive layer.

60. The method of claim 56 wherein the charge carrying,
 host material is a hole transporting material.

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61. The method of claim **56** wherein the charge carrying, host material is an electron transporting material.

62. The method of claim **56** wherein the phosphorescent material has a phosphorescent lifetime not longer than about 10 microseconds.

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63. The method of claim **56** wherein the phosphorescent material has a phosphorescent lifetime from about 10 to about 100 microseconds.

* * * * *

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,303,238 B1
APPLICATION NO. : 08/980986
DATED : October 16, 2001
INVENTOR(S) : Thompson et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

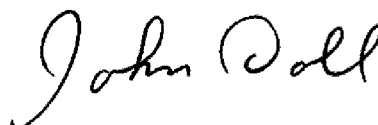
Column 1, line 8, please insert the following paragraph:

--GOVERNMENT RIGHTS

This invention was made with Government support under Contract No. F33615-94-1-1414 awarded by DARPA. The government has certain rights in this invention.--

Signed and Sealed this

Twenty-first Day of April, 2009



JOHN DOLL
Acting Director of the United States Patent and Trademark Office